


Guojin Chen

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Last updated on June 7, 2026

Current Position


 **HUAWEI** **Researcher**, *Huawei Foundation Models Lab*, Hong Kong, China 2025.09 – Present

- Focused on post-training for coder foundation models, enhancing reasoning, code generation, and instruction-following capabilities through reinforcement learning and supervised fine-tuning.
- Led the development of the coding data infrastructure platform, including code exercise curation pipelines, sandboxed execution environments, and production-grade data processing workflows.
- Contributed to the development of an internal agent scaffolding framework, enabling rapid prototyping and deployment of LLM-powered agentic systems.

Experiences

 **DeepMind** **Google DeepMind**, *Ph.D. Student Researcher* 2024.07 – 2024.10
Mountain view, CA

 **NVIDIA**, *Research Scientist Intern* 2024.04 – 2024.07
(Mentor & Manager: Haoyu Yang & Mark Ren) Austin, TX

 **University of Texas at Austin**, *Visiting Scholar* 2023.08 – 2024.4
(Supervisor : Prof. David Z. Pan) Austin, TX

 **Tencent**, *Intern* 2018
Shenzhen, China

Education

Ph.D. in Computer Science, *Chinese University of Hong Kong* 2021 – 2025
Supervisor : Prof. Bei Yu

M.S. in Computer Science, *Chinese University of Hong Kong* 2019 – 2020

B.S. in Computer Science, *Huazhong University of Science and Technology* 2015 – 2019

Research Interests

Research Overview

To learn more about my research, click [this link](#) for a detailed document with rich text and images.

- Large language models: post-training, agentic native LLMs, multimodal LLMs.
- Design for manufacturing: computational lithography, OPC, SMO.
- Optimization: bi-level, multi-level optimization, level-set optimization, GPU acceleration.

Publications [Google Scholar; 696+ citations, h-index: 14+]

Representative publications that I am a primary author on are **highlighted**.

Conference papers

[C20] Fast Inverse Lithography via GRPO Reinforced Flow Matching
Yao Lai, Xuyuan Xiong, Zeyue Xue, **Guojin Chen**, Jing Wang, Xihui Liu, Rui Zhang,
Robert D. Mullins, Bei Yu, and Ping Luo
(**ICML 2026**) *Forty-third International Conference on Machine Learning*

[C19] Intelligent OPC Engineer Assistant for Semiconductor Manufacturing
Guojin Chen, Haoyu Yang, Bei Yu, and Haoxing Ren
(**AAAI 2025**) *The 39th Annual AAAI Conference on Artificial Intelligence*

- [C18] AnalogCoder: Analog Circuit Design via Training-Free Code Generation
Yao Lai, Sungyoung Lee, **Guojin Chen**, Souradip Poddar, Mengkang Hu, David Z Pan, and Ping Luo
(**AAAI 2025**) *The 39th Annual AAAI Conference on Artificial Intelligence*
- [C17] PACE: Pacing Operator Learning to Accurate Optical Field Simulation for Complicated Photonic Devices
Hanqing Zhu, Wenyan Cong, **Guojin Chen**, Shupeng Ning, Ray Chen, Jiaqi Gu, and David Z. Pan
(**NeurIPS 2024**) *The Thirty-eighth Annual Conference on Neural Information Processing Systems*
- [C16] Differentiable Edge-based OPC
Guojin Chen, Haoyu Yang, Haoxing Ren, Bei Yu, and David Z. Pan
(**ICCAD 2024**) *Proceedings of the 43rd International Conference on Computer-Aided Design*
- [C15] Efficient Bilevel Source Mask Optimization
Guojin Chen, Hongquan He, Peng Xu, Hao Geng, and Bei Yu
(**DAC 2024**) *ACM/IEEE Design Automation Conference*
- [C14] Fracturing-aware Curvilinear ILT via Circular E-beam Mask Writer
Xinyun Zhang, Su Zheng, **Guojin Chen**, Binwu Zhu, Hong Xu, and Bei Yu
(**DAC 2024**) *ACM/IEEE Design Automation Conference*
- [C13] Performance-driven Analog Routing via Heterogeneous 3DGNN and Potential Relaxation
Peng Xu, **Guojin Chen**, Keren Zhu, Tinghuan Chen, Tsung-Yi Ho, and Bei Yu
(**DAC 2024**) *ACM/IEEE Design Automation Conference*
- [C12] Open-Source Differentiable Lithography Imaging Framework
Guojin Chen, Hao Geng, Bei Yu, and David Z. Pan
(**SPIE 2024**) *SPIE Advanced Lithography + Patterning*
- [C11] AlphaSyn: Logic Synthesis Optimization with Efficient Monte Carlo Tree Search
Zehua Pei, Fangzhou Liu, Zhuolun He, **Guojin Chen**, Haisheng Zheng, Keren Zhu, and Bei Yu
(**ICCAD 2023**) *Proceedings of the 42th International Conference on Computer-Aided Design*
- [C10] Physics-Informed Optical Kernel Regression Using Complex-valued Neural Fields
Guojin Chen, Zehua Pei, Haoyu Yang, Yuzhe Ma, Bei Yu, and Martin Wong
(**DAC 2023**) *ACM/IEEE Design Automation Conference* ([Best score in DFM track.](#))
- [C9] DiffPattern: Layout Pattern Generation via Discrete Diffusion
Zixiao Wang, Yunheng Shen, Wenqian Zhao, Yang Bai, **Guojin Chen**, Farzan Farnia, and Bei Yu
(**DAC 2023**) *ACM/IEEE Design Automation Conference*
- [C8] GPU-accelerated Matrix Cover Algorithm for Multiple Patterning Layout Decomposition
Guojin Chen, Haoyu Yang, and Bei Yu
(**SPIE 2023**) *DTCO and Computational Patterning II*
- [C7] Efficient Point Cloud Analysis Using Hilbert Curve.
Wanli Chen, Xinge Zhu, **Guojin Chen**, and Bei Yu
(**ECCV 2022**) *European Conference on Computer Vision*
- [C6] AdaOPC: A Self-Adaptive Mask Optimization Framework For Real Design Patterns
Wenqian Zhao, Xufeng Yao, Ziyang Yu, **Guojin Chen**, Yuzhe Ma, Bei Yu, and Martin Wong
(**ICCAD 2022**) *Proceedings of the 41th International Conference on Computer-Aided Design*
- [C5] LayoutTransformer: Generating Layout Patterns with Transformer via Sequential Pattern Modeling
Liangjian Wen, Yi Zhu, Lei Ye, **Guojin Chen**, Bei Yu, Jianzhuang Liu, and Chunjing Xu
(**ICCAD 2022**) *Proceedings of the 41th International Conference on Computer-Aided Design*
- [C4] DevelSet: Deep Neural Level Set for Instant Mask optimization
Guojin Chen, Ziyang Yu, Hongduo Liu, Yuzhe Ma, and Bei Yu
(**ICCAD 2021**) *Proceedings of the 40th International Conference on Computer-Aided Design*
- [C3] Learning Point Clouds in EDA.
Wei Li, **Guojin Chen**, Haoyu Yang, Ran Chen, and Bei Yu
(**ISPD 2021**) *ACM International Symposium on Physical Design*

- [C2] DAMO: Deep Agile Mask Optimization for Full Chip Scale
Guojin Chen, Wanli Chen, Yuzhe Ma, Haoyu Yang, and Bei Yu
 (ICCAD 2020) *Proceedings of the 39th International Conference on Computer-Aided Design*
- [C1] A GPU-enabled Level Set Method for Mask Optimization
 Ziyang Yu, **Guojin Chen**, Yuzhe Ma, and Bei Yu
 (DATE 2020) *IEEE/ACM Proceedings Design, Automation and Test in Europe*

Journal papers.....

- [J11] Efficient Bilevel Source Mask Optimization
Guojin Chen, Peng Xu, Hongquan He, Hao Geng, and Bei Yu
 (TCAD 2026) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J10] AnalogCoder-Pro: Unifying Analog Circuit Generation and Optimization via Multi-modal LLMs
 Yao Lai, Souradip Poddar, Sungyoung Lee, **Guojin Chen**, Mengkang Hu, Bei Yu, Ping Luo, and David Z. Pan
 (TCAD 2026) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J9] DiffPattern-Flex: Efficient Layout Pattern Generation via Discrete Diffusion
 Zixiao Wang, Wenqian Zhao, Yunheng Shen, Yang Bai, **Guojin Chen**, Farzan Farnia, and Bei Yu
 (TCAD 2025) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J8] PARoute2: Enhanced Analog Routing via Performance-Drive Guidance Generation
 Peng Xu, Jindong Tu, **Guojin Chen**, Keren Zhu, Tinghuan Chen, Tsung-Yi Ho, and Bei Yu
 (TCAD 2025) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J7] RuleLearner: OPC Rule Extraction from Inverse Lithography Technique Engine
 Ziyang Yu, Su Zheng, Wenqian Zhao, Shuo Yin, Xiaoxiao Liang, **Guojin Chen**, Yuzhe Ma, Bei Yu, and Martin D.F. Wong
 (TCAD 2024) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J6] DeepOTF: Learning Equations-constrained Prediction for Electromagnetic Behavior
 Peng Xu, Siyuan Xu, Tinghuan Chen, **Guojin Chen**, Tsung-Yi Ho, and Bei Yu
 (TODAES 2024) *ACM Trans. Des. Autom. Electron. Syst.*
- [J5] Ultra-Fast Source Mask Optimization via Conditional Discrete Diffusion
Guojin Chen, Zixiao Wang, Bei Yu, David Z. Pan, and Martin D.F. Wong
 (TCAD 2024) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J4] L2O-ILT: Learning to Optimize Inverse Lithography Techniques
 Binwu Zhu, Su Zheng, Ziyang Yu, **Guojin Chen**, Yuzhe Ma, Fan Yang, Bei Yu, and Martin Wong
 (TCAD 2023) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J3] A GPU-Enabled Level-Set Method for Mask Optimization
 Ziyang Yu, **Guojin Chen**, Yuzhe Ma, and Bei Yu
 (TCAD 2023) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J2] DevelSet: Deep Neural Level Set for Instant Mask optimization
Guojin Chen, Ziyang Yu, Hongduo Liu, Yuzhe Ma, and Bei Yu
 (TCAD 2023) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*
- [J1] DAMO: Deep Agile Mask Optimization for Full-Chip Scale
Guojin Chen, Wanli Chen, Qi Sun, Yuzhe Ma, Haoyu Yang, and Bei Yu
 (TCAD 2022) *IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems*

Preprints.....

- [P1] LLM-Enhanced Bayesian Optimization for Efficient Analog Layout Constraint Generation
Guojin Chen, Keren Zhu, Seunggeun Kim, Hanqing Zhu, Yao Lai, Bei Yu, and David Z Pan
 (arXiv 2024) *arXiv preprint arXiv:2406.05250*

Open Source Repositories

1. TorchOPC/TorchLitho ★224 *Differentiable computational lithography with PyTorch*

2024

2. dekura/LLANA ★32 *LLM-Enhanced Bayesian Optimization for Efficient Analog Constraint Generation* 2024
3. OpenOPC/OpenILT ★221 *Open-source inverse lithography technology (ILT) framework* 2023
4. ai4eda/awesome-AI4EDA ★198 *A curated paper list of existing AI for EDA studies.* 2023

Awards

Ph.D. Studentship	2021 – 2025
<small>By Chinese University of Hong Kong, 2021-2025</small>	
Outstanding Graduate	2019
<small>By Huazhong University of Science and Technology</small>	

Professional Activities

Paper Review / External Review	
Neural Information Processing Systems (NeurIPS)	2023-2024
Design Automation Conference (DAC)	2021-2024
AAAI Conference on Artificial Intelligence (AAAI)	2022-2025
IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems (TCAD)	2022-2024